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(12) **United States Design Patent**
Yoshida et al.

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(54) **BOAT FOR SUBSTRATE PROCESSING APPARATUS**

(56) **References Cited**

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(52) **U.S. Cl.**
USPC **D13/182**

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118/715, 500, 728, 729; 211/41.18;
432/253, 258; 156/345.51, 345.52,
156/345.53, 345.55; 414/217, 220.01, 935,
414/936-941
CPC C23C 16/458; C23C 16/4581; C23C
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C23C 16/4586; C23C 16/4587; C23C
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21/67303; H01L 21/67306; H01L 21/67309;
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21/37323; H01L 21/67326; H01L 21/6733
See application file for complete search history.

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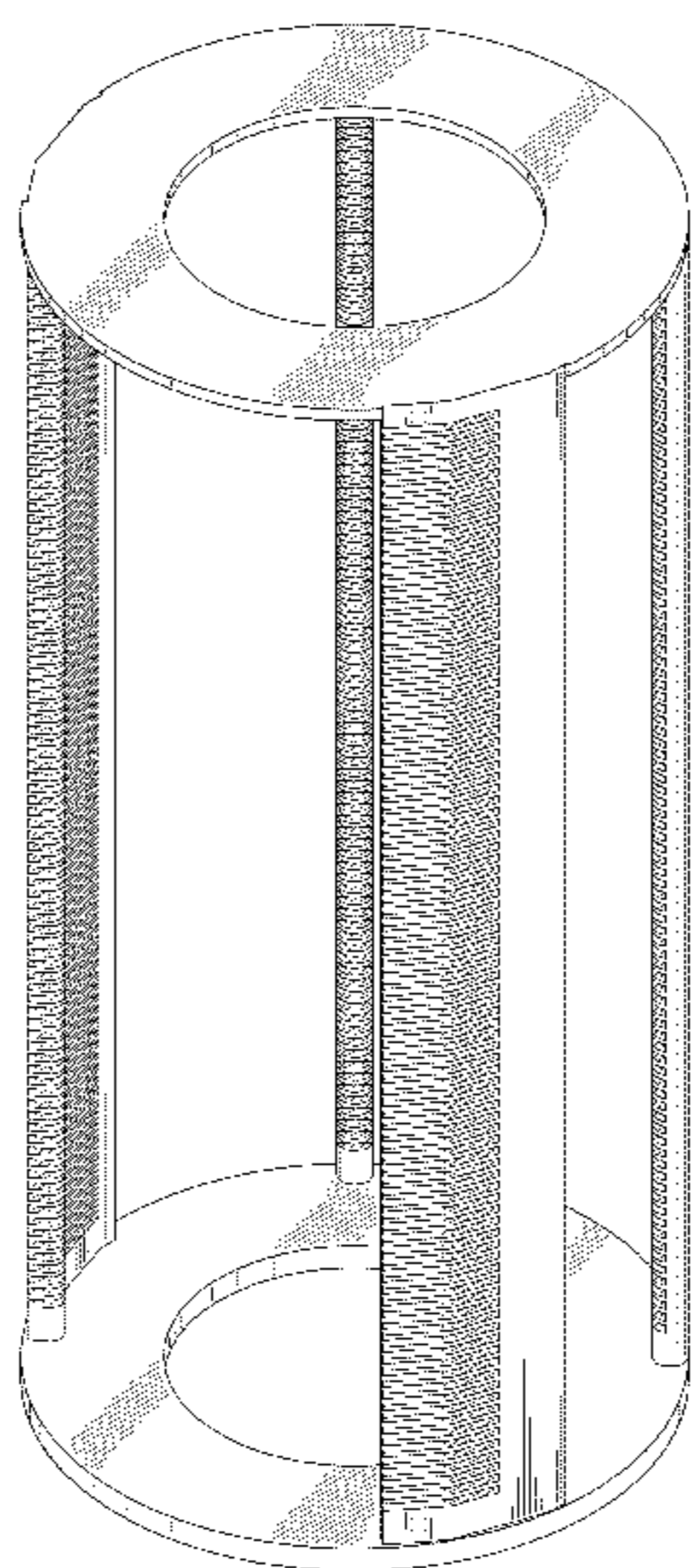
(57) **CLAIM**

The ornamental design for a boat for substrate processing apparatus, as shown and described.

DESCRIPTION

FIG. 1 is a front, top and right side perspective view of a boat for substrate processing apparatus showing our new design; FIG. 2 is a front elevational view thereof; FIG. 3 is a rear elevational view thereof; FIG. 4 is a left side elevational view thereof; FIG. 5 is a right side elevational view thereof; FIG. 6 is a top plan view thereof; FIG. 7 is a bottom plan view thereof; FIG. 8 is a cross sectional view taken along line 8-8 in FIG. 2; and, FIG. 9 is a cross sectional view taken along line 9-9 in FIG. 2.

1 Claim, 8 Drawing Sheets



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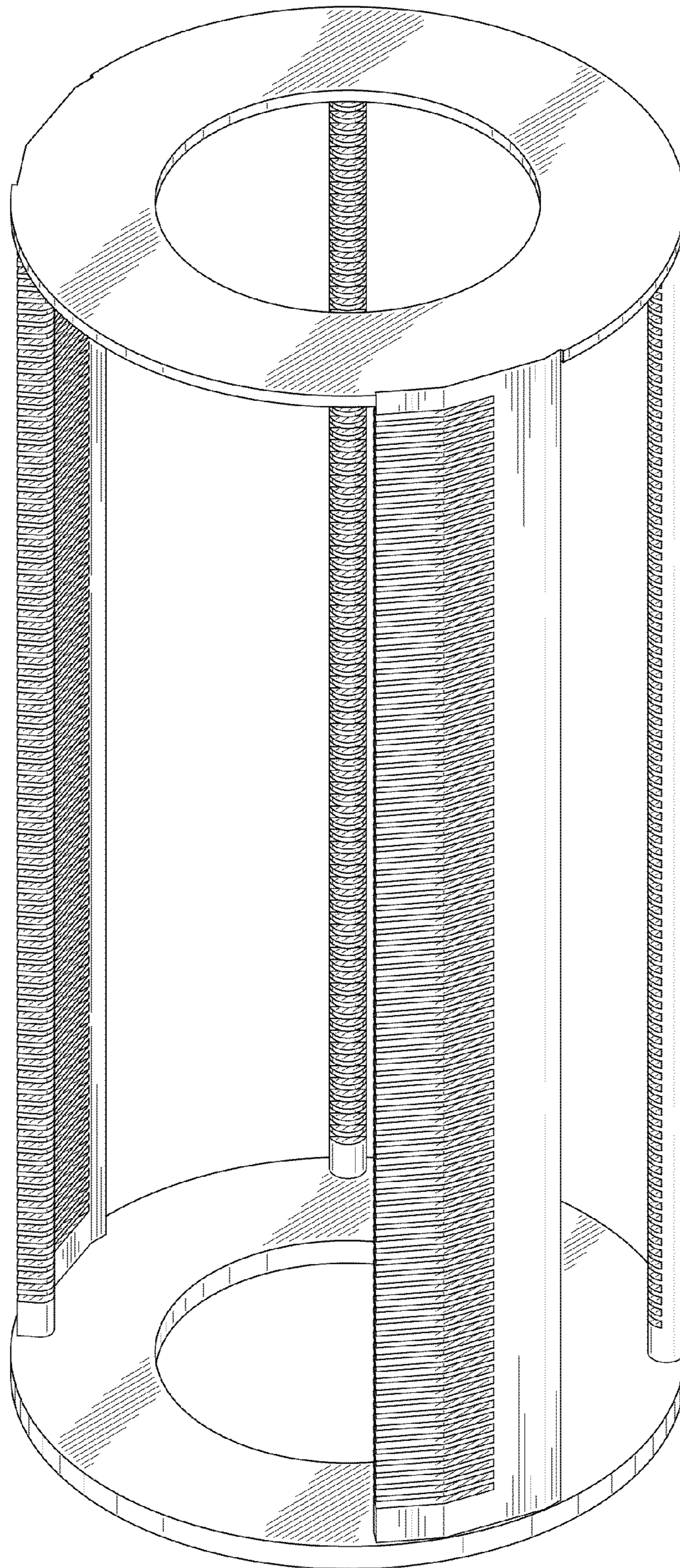
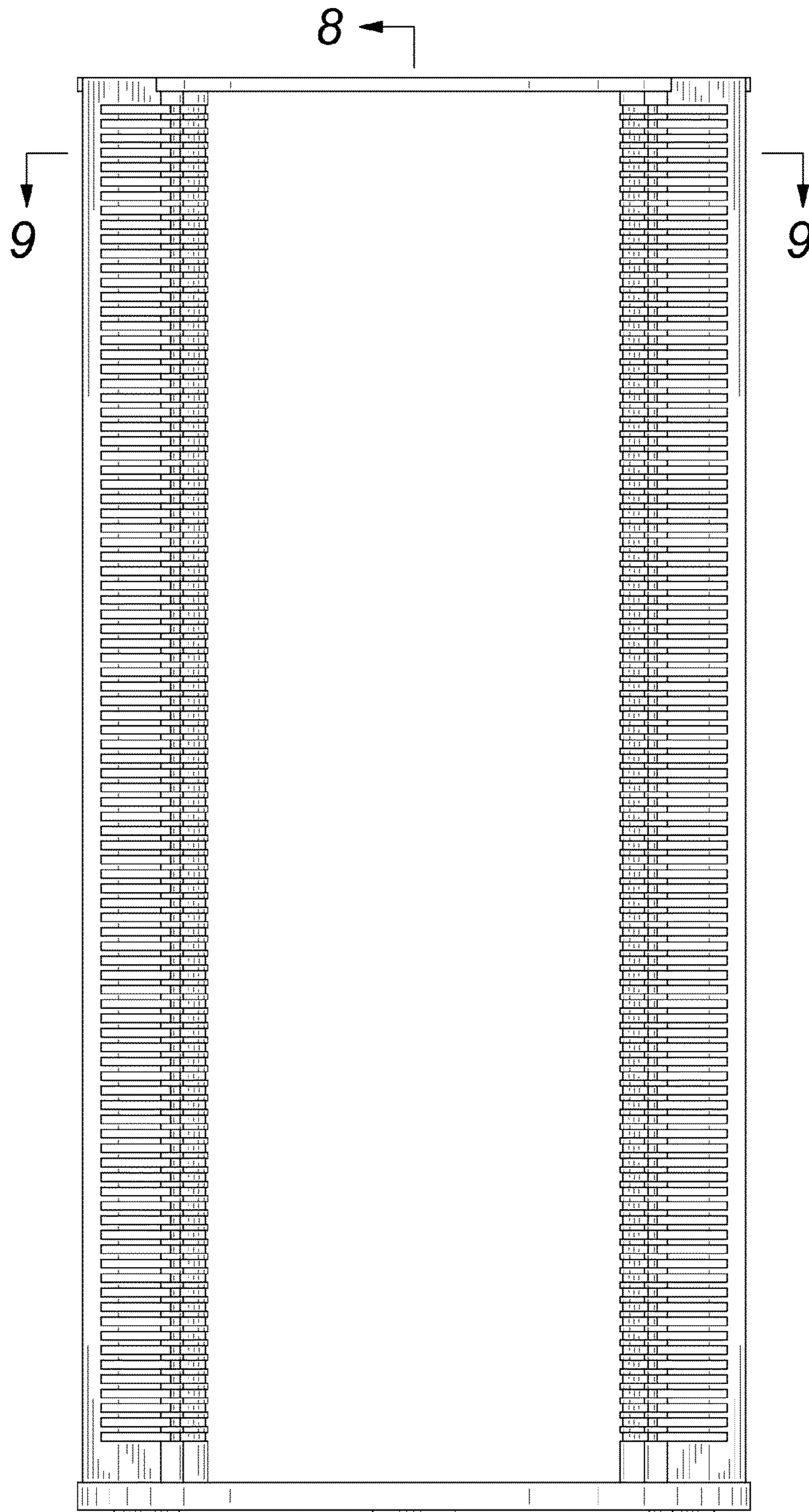


FIG. 1



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FIG. 2

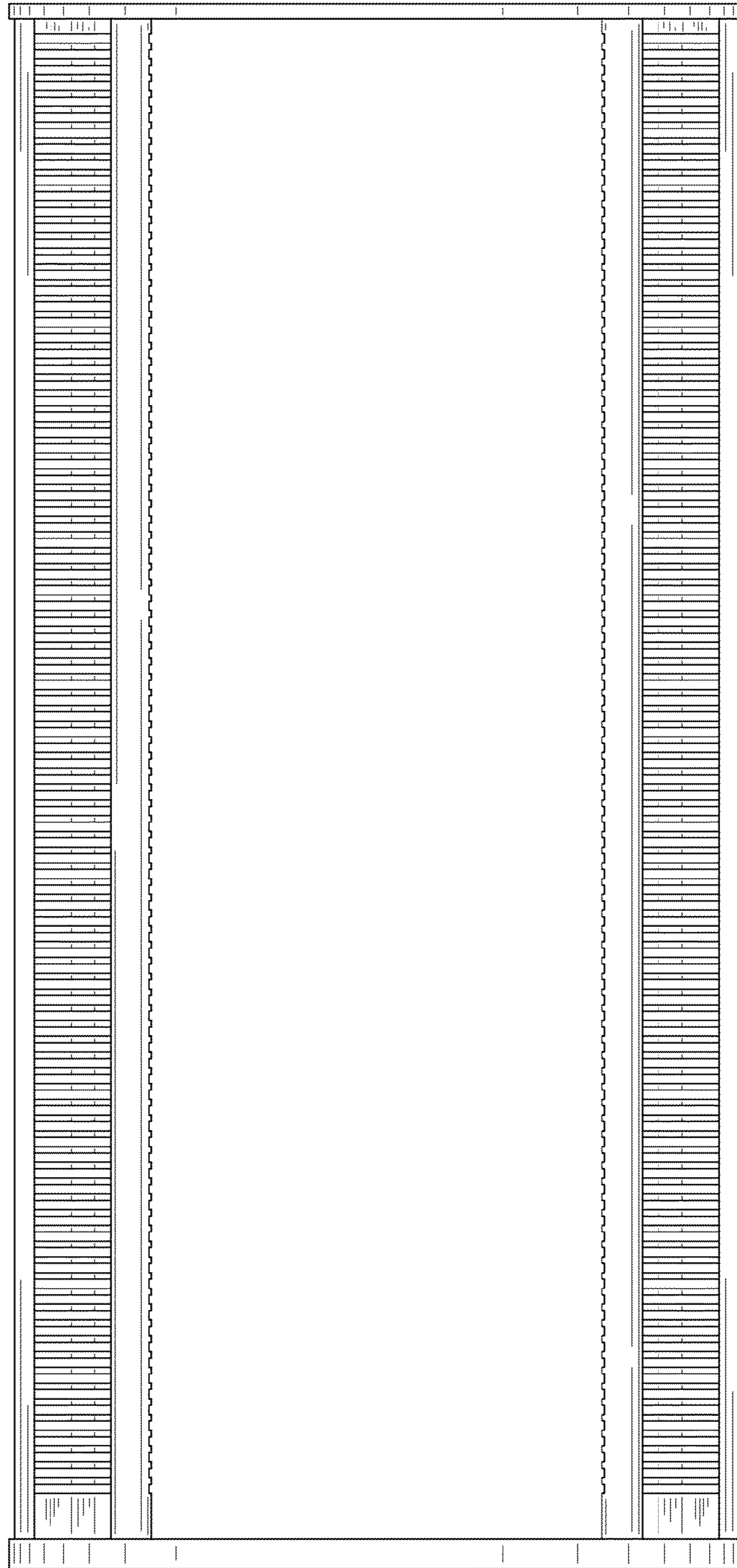


FIG. 3

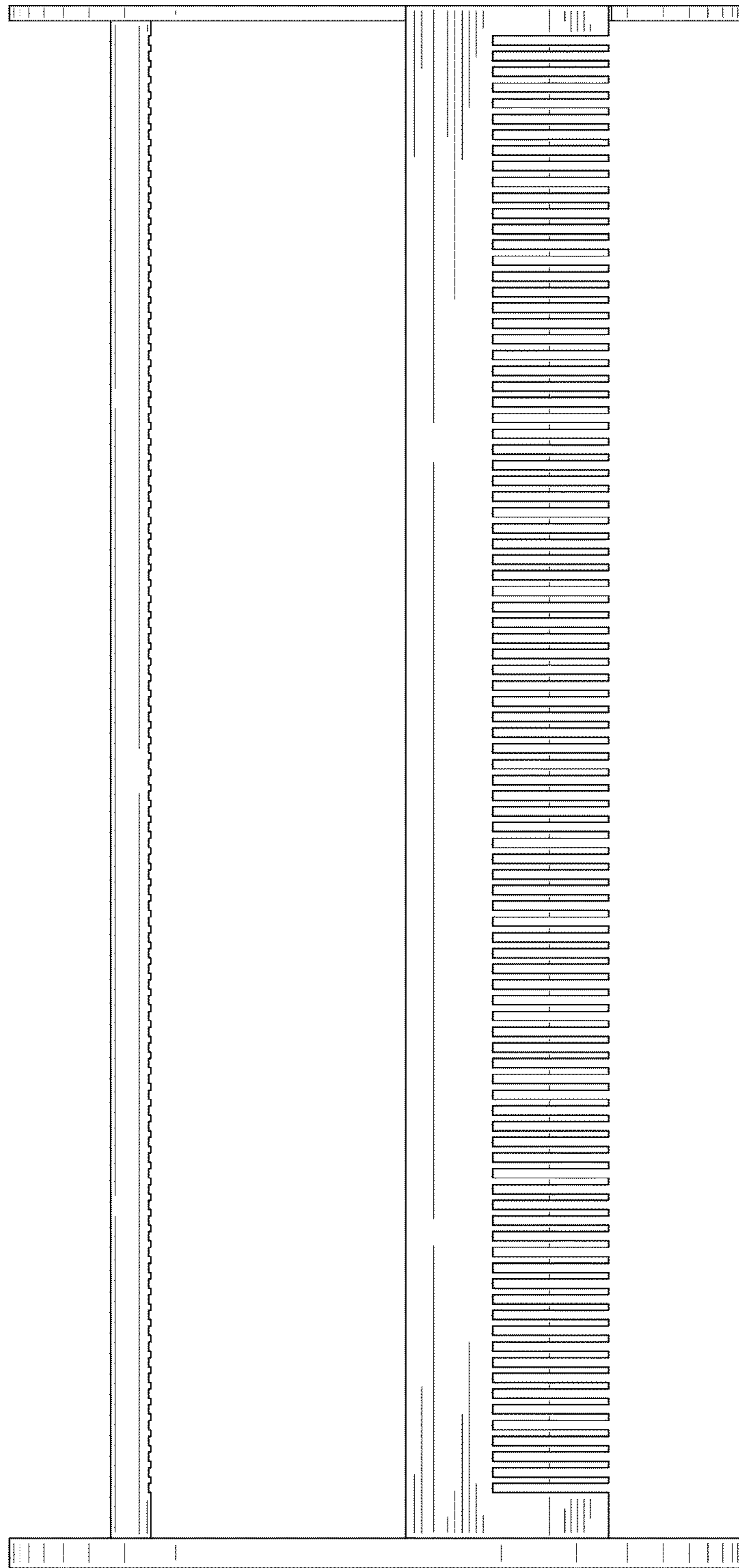


FIG. 4

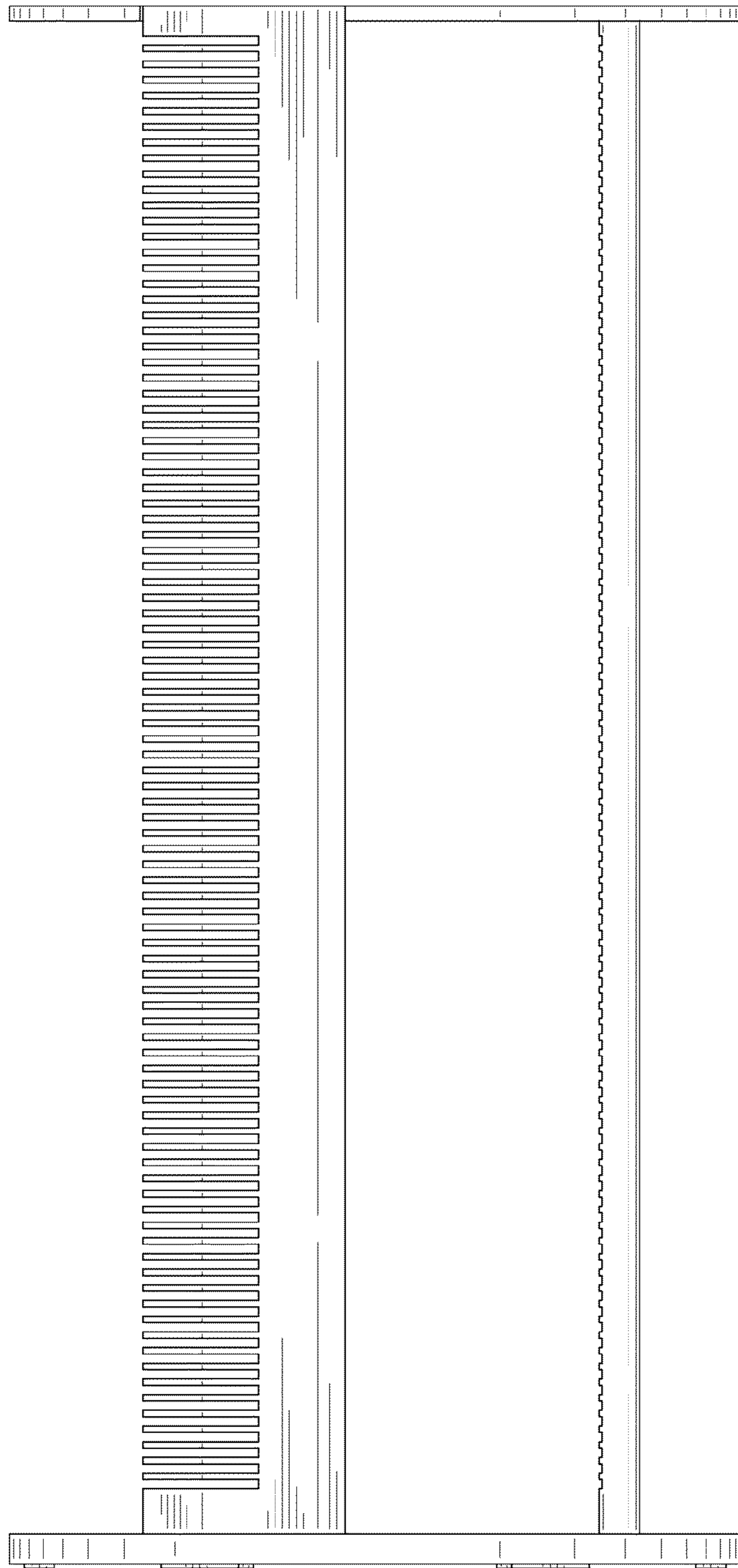


FIG. 5

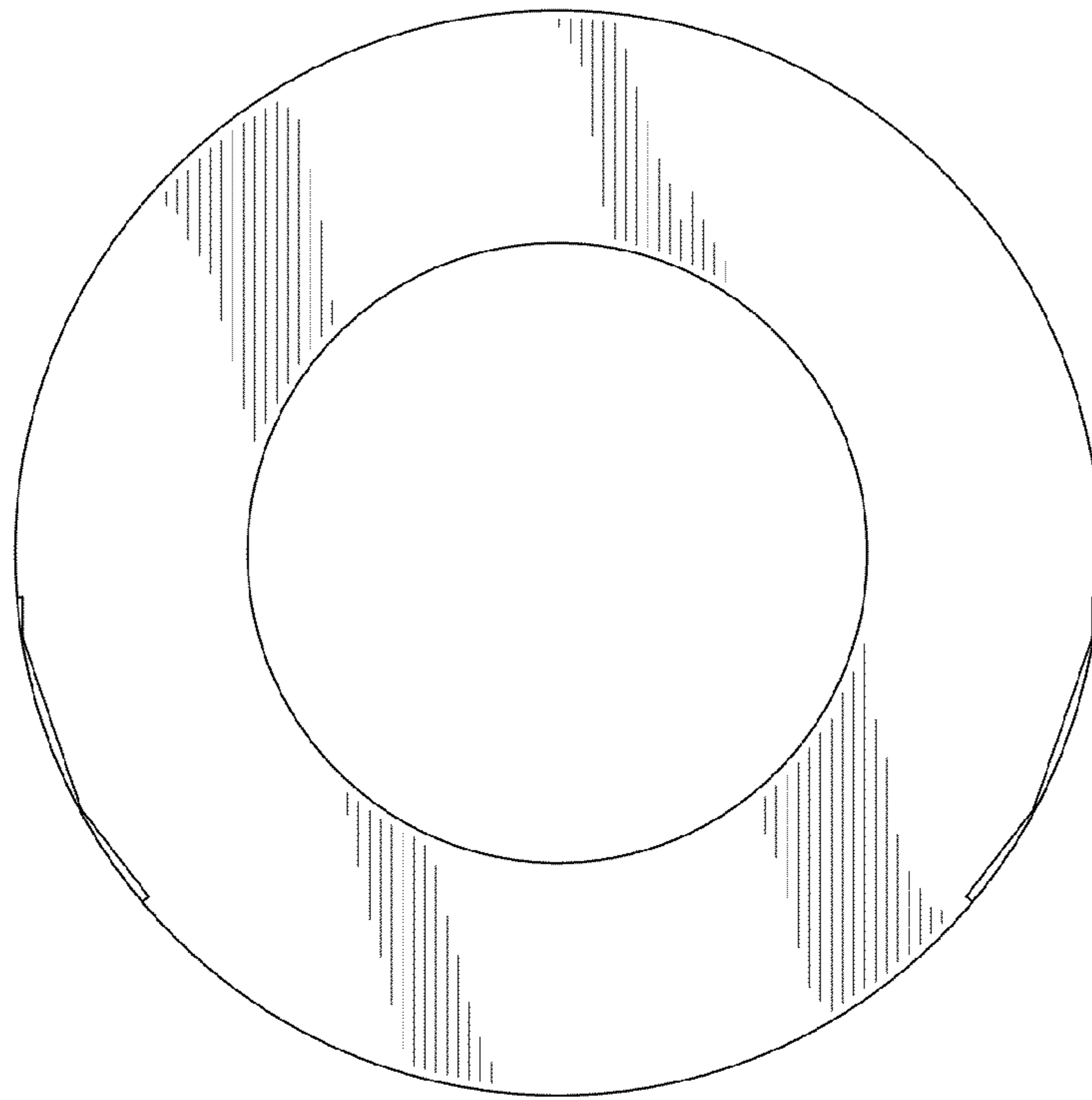


FIG. 6

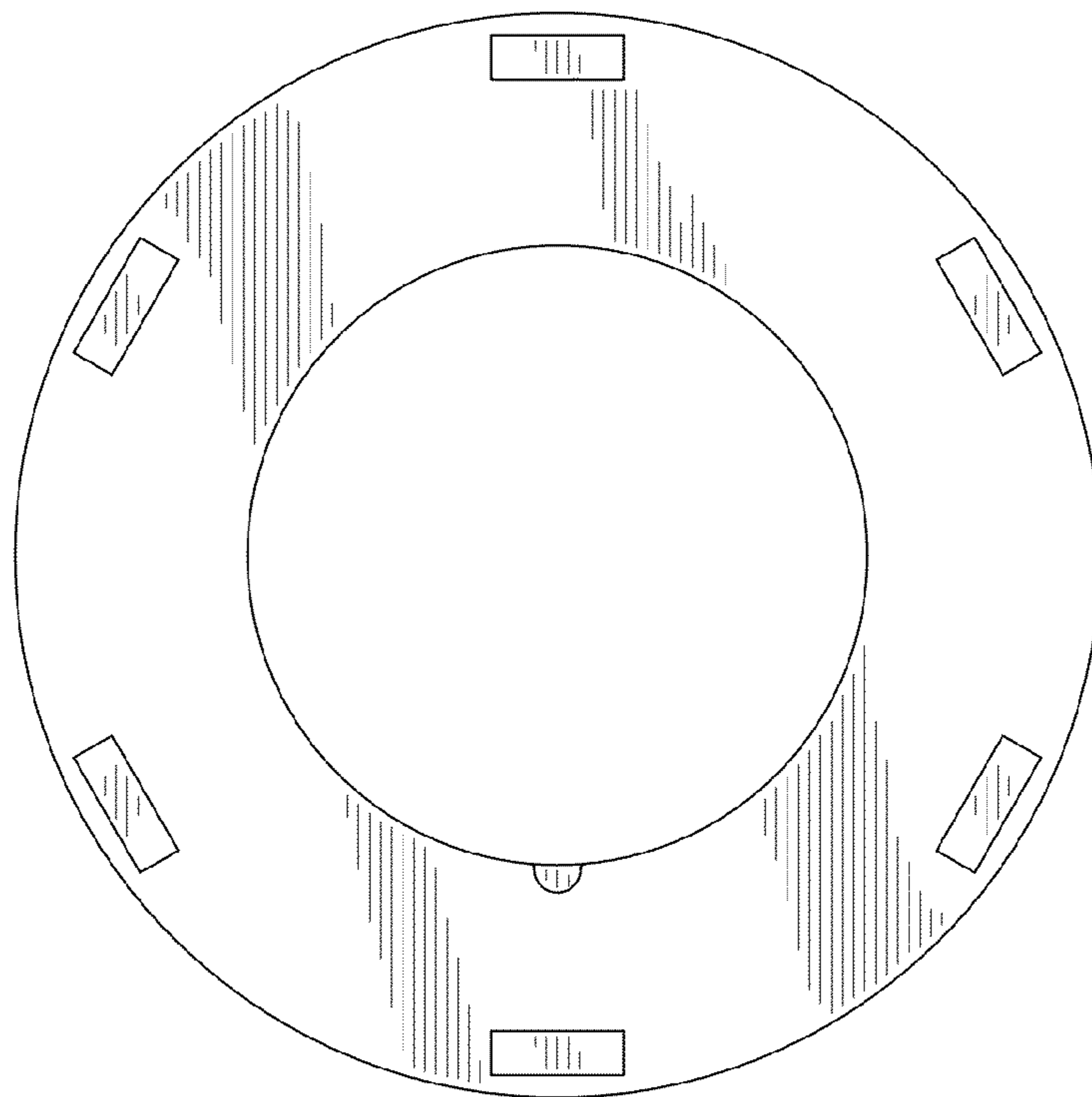


FIG. 7

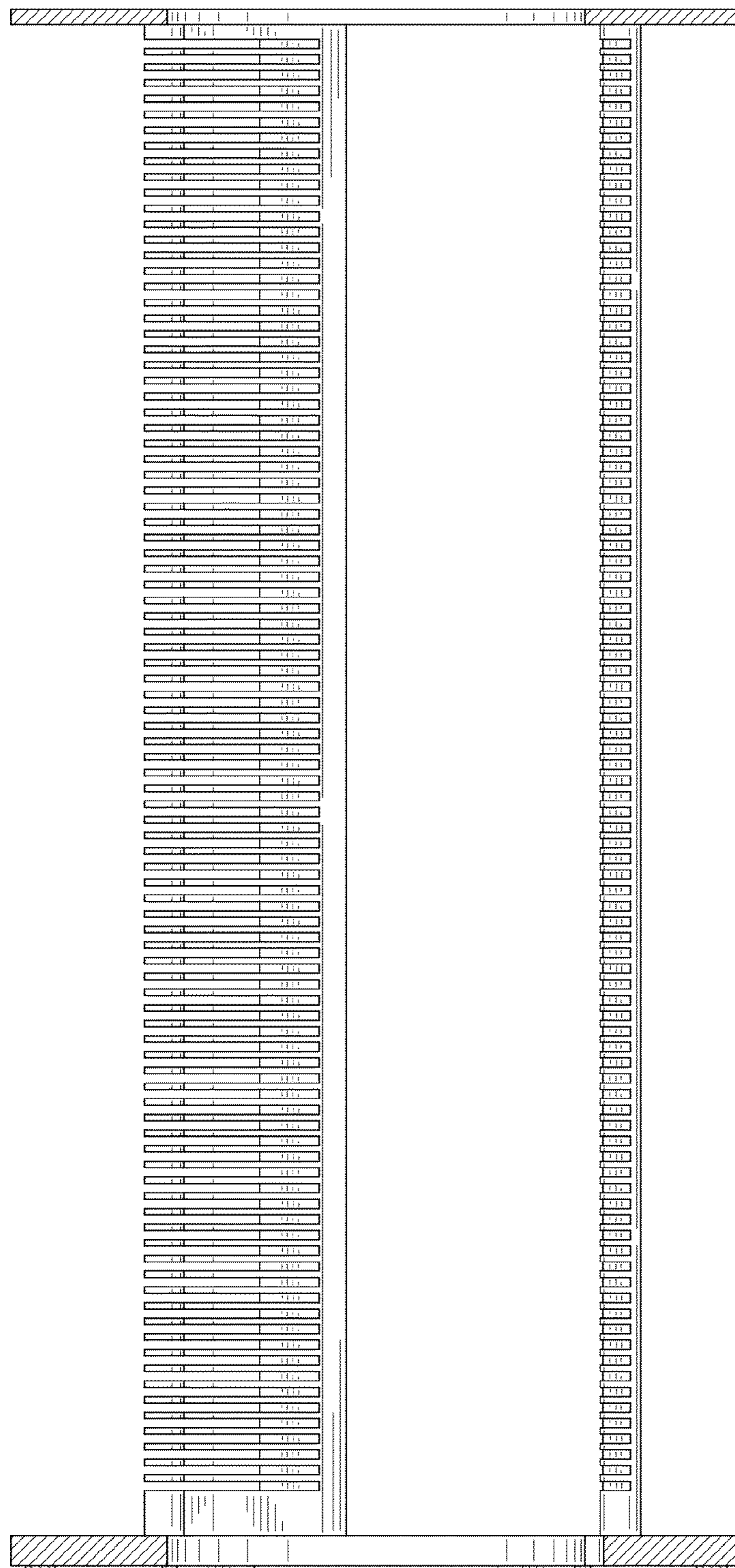


FIG. 8

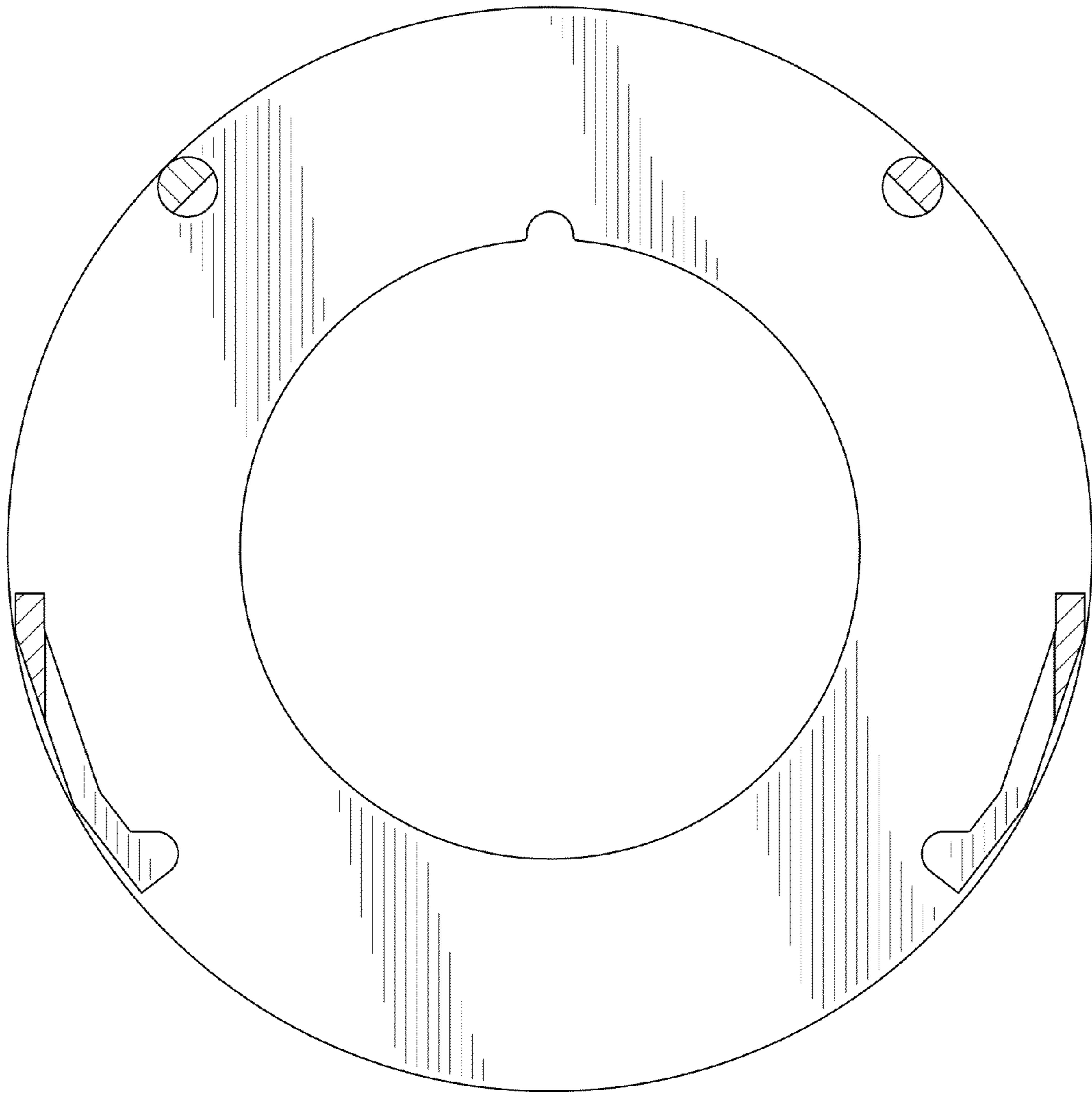


FIG. 9